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APPLICANT
Shozo Nagano et al.

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GROUP
1742

LIST OF ART CITED BY APPLICANT
(Use several sheets if necessary)

U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
CZ	AA	4,189,084	02-1980	Johnson et al.			
	AB	09/556,488		J. Kardokus (Amendment dated 7-10-01)			04-21-2000
	AC	09/714,714		J. Kardokus (Amendment dated 5-22-02)			11-15-2000
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
CZ	AL	85104006	01-1986	China (abstract)				
CZ	AM	62036798	08-1987	Japan (abstract)				
CZ	AN	61227972	10-1986	Japan (abstract)				
CZ	AO	49007777	02-1974	Japan (abstract)				
CZ	AP							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

CZ	AR		Reda et al., "Amorphous copper-silver films with high stability", Int. Cent. Theor. Phys., Trieste, Italy, 1983. (Abstract only) The year is sufficiently early so that the month is not in issue.
CZ	AS		U.S. patent application, 09/556,488, Kardokus, filed 4/21/00
CZ	AT		U.S. patent application, 09/714,714, Kardokus, filed 2/14/01

EXAMINER S. IP

DATE CONSIDERED 12/15/02

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.